## Extrinsic Electrons and Carrier Accumulation in Al<sub>x</sub>In<sub>1-x</sub>Sb/InSb Quantum Wells: Well-Width Dependence

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Abstract. Hall coefficient ( $R_{\rm H}$ ) and magnetoresistance (MR) effects were studied at room temperature and 77 K for undoped quantum well (QW) structures of InSb sandwiched by Al<sub>0.1</sub>In<sub>0.9</sub>Sb alloy grown by molecular beam epitaxy on GaAs substrates. As the result of two-carrier analyses of  $R_{\rm H}$ , it was found that the sheet density of the extrinsic electrons at room temperature decreases with the increase of the well width above 100 nm. At 77 K the electrons extended in the QW show the negative longitudinal MR in magnetic fields parallel to the QW, which originates in specular boundary scattering in the classical orbits at the walls of barriers.

A quantum well (QW) structure of InSb with  $Al_xIn_{1-x}Sb$  barriers has been considered to be an ideal system for electronic device applications such as magnetic sensors and high-speed transistors. In this QW structure, an  $Al_xIn_{1-x}Sb$  barrier layer is often selectively  $\delta$ -doped in order to supply the carriers to the QW [1]. This is not due to absence of extrinsic carriers but due to the small mobility of existing extrinsic electrons accumulated at the heterointerface even when neither InSb nor the barrier region is intentionally doped. In the undoped InSb QW structures, two sources of extrinsic electrons are expected: deep donors in the barrier layers and shallow donors in InSb. The electrons falling into the QW from the deep donors will result in the band bending near the interface, producing the accumulation layer.

Classical size effects of magnetoresistance (MR) in semiconductors arising from the boundary scattering in the quasi-ballistic regime have been studied in the QWs [2], the ion-beam exposed channels of two-dimensional electron systems [3] and the quantum dots [4]. In the case of specular boundary scattering (SBS), negative MR appears, which originates in the suppression of the backward scattering of electrons by impurities under a magnetic fields because of the cyclotron motion. SBS requires that the length scale of roughness at the boundary is much smaller than the Fermi wavelength  $\lambda_{\rm F}$ . Our InSb QW satisfies this condition.

In order to investigate the transport properties of the extrinsic electrons of InSb QWs, we have measured the Hall coefficient  $(R_H)$  and MR. InSb QWs

were sandwiched by  $Al_{0.1}In_{0.9}Sb$  alloys grown on GaAs(100) substrates by molecular beam epitaxy. The samples were capped by a 6 nm-thick GaAs layer [5]. The lattice mismatch between the QW and the barriers is 0.5 %. The Hall and MR measurements for the QWs with different well widths ( $L_{\rm w}=15\sim300$  nm) were performed under the magnetic fields (B) up to 1.5 T at room temperature (RT) and 77 K. The sample parameters for various  $L_{\rm w}$  at 77 K are given in Table 1.

At RT the carrier concentration for our InSb OWs is larger than the intrinsic one (= 2.0 x 1016 cm-3) in bulk InSb indicating that there are extrinsic carriers. Moreover, the B-dependence of  $R_{\rm H}$  for  $L_{\rm w} = 30$  nm as shown in the inset in Fig.1(a) indicates the two-carrier conduction, while for  $L_w = 200$  nm  $R_{\rm H}$  is almost independent of B at RT. As regards the two carriers, we assume that one is the electron with high mobility which is extended in the QW and the other is the accumulated one with low mobility at the hetero-interface. Although there is not much difference in the sheet resistance between InSb QWs and InSb films grown directly on GaAs, the electron mobility of InSb QWs in thin regions of less than 0.5 µm was significantly higher compared with InSb films on GaAs substrates [5]. These results indicate that there is a low-mobility layer at the hetero-interface. Fig. 1(a) show the  $L_w$ -dependence of the sheet density of the extended electrons  $(n_w)$  and the accumulated ones  $(n_{ac})$ estimated by the two-carrier analysis, It is found that  $n_w$  at RT increases and nac decreases gradually as Lw increases. We obtained the sheet density of extrinsic electrons  $(n_{w(ex)})$  at RT estimated by subtracting the one of intrinsic electrons  $(n_i)$  from  $n_w$  as shown in the left hand of Fig.1(a). The decrease in  $n_{w(ex)}$  at RT with the increase of  $L_w$  above 100 nm is quite anomalous. This is different from the increase behavior followed by the saturation of  $n_{w(ex)}$  found in InAs QWs reported in our previous paper [2]. The difference between them is the depth of the QW. It is shallow for InSb QWs, whereas it is deep for InAs QWs. There is a possibility that more electrons in InSb QWs with increasing L<sub>w</sub> return to deep donors and the band bending near the interface becomes smaller. Therefore, a crossover from two-carrier conduction to one-

**Table 1.** Sample parameters for InSb QWs at 77 K, where  $R_s$  is the sheet resistance,  $\mu_w$  ( $\mu_{ac}$ ) the mobility of the extended (accumulated) electrons and  $L_0$  the mean free path.

L <sub>w</sub> (nm)	$R_s$ $(10^4\Omega)$	n <sub>w</sub> (10 <sup>11</sup> cm <sup>-2</sup> )	n <sub>ac</sub> (10 <sup>11</sup> cm <sup>-2</sup> )	μ <sub>w</sub> (10 <sup>3</sup> cm <sup>2</sup> /Vs)	$\mu_{ac}$ (cm <sup>2</sup> /Vs)	λ <sub>F</sub> (nm)	L <sub>0</sub> (nm)	B <sub>s</sub> (T)	d <sub>elf</sub> (nm)
15	14	1.9	1.0	0.23	5.0	87	1.7		
30	13	2.2	0.99	0.22	2.3	81	1.7		
70	2.9	3.1	1.8	0.70	1.2	68	6.4		
100	2.4	1.3	0.56	2.0	1.5	100	12	0.96	130
150	2.1	1.3	0.18	2.1	20	100	13	0.75	160
200	0.69	1.4	0.90	6.3	1.0	100	39	0.68	180
300	0.58	1.0	0.31	11	3.5	120	- 56	0.48	220

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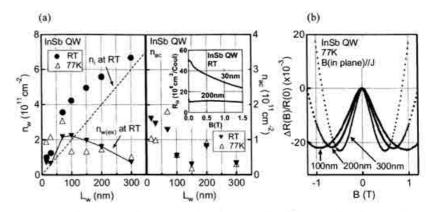


Fig. 1. (a) Left figure:  $L_w$ -dependence of the sheet density of the extended electrons  $(n_w)$  at RT and 77 K. Broken line represents the sheet density of intrinsic electrons  $(n_i)$  at RT.  $\nabla$  means the sheet density of extrinsic electrons  $(n_{w(ex)})$  estimated by subtracting  $n_i$  from  $n_w$ . Right figure:  $L_w$ -dependence of the sheet density of the accumulated electrons  $(n_{ac})$  at RT and 77 K. Inset: Normalized  $R_H$  by  $L_w$  for 30 nm and 200 nm at RT. (b) Longitudinal MR under in-plane magnetic fields at 77 K.

carrier one is considered to be observed as shown in the inset in Fig.1(a).

The perpendicular MR for InSb QWs at 77 K is positive one proportional to  $B^2$  due to Lorentz force, whereas the longitudinal MR in the parallel fields always starts from the negative one as shown in Fig.1(b), reaching a minimum at the characteristic magnetic field ( $B_{\rm S}$ ) followed by the classical positive MR with  $B^2$  dependence with increasing field. As the  $L_{\rm w}$  is wider, the value of  $B_{\rm S}$  shifts to lower fields, arising from SBS in the quasi-ballistic regime at the walls of barriers [3]. Saturation of the negative MR associated with SBS occurs at  $B > B_{\rm S} = 2m_{\rm e}v_{\rm F}/ed_{\rm eff}$ , where  $v_{\rm F}$  is the electron Fermi velocity and  $d_{\rm eff}$  the effective QW width. As for the QW with  $L_{\rm w} \ge 100$  nm, we derived  $d_{\rm eff}$  from the cyclotron diameter at  $B_{\rm S}$  and found that  $d_{\rm eff}$  is almost equal to  $L_{\rm w}$  as shown in Table 1. These results show that the SBS and the high-mobility electrons extended in the QW play important roles for the negative MR.

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